

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

METHOD OF FORMING STRAINED SILICON MATERIALS
WITH IMPROVED THERMAL CONDUCTIVITY

Application Number :

Confirmation Number:

First Named Applicant: Stephen Bedell

Attorney Docket Number: FIS920040069

Art Unit:

Examiner:

Search string: (20040004271).pn

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20040004271	2004-01-08	Fukuda et al.			

Signature

Examiner Name	Date